## Amendments to the Specification

Please replace the title as follows:

CERAMIC FILM, METHOD OF FABRICATING THE SAME, FERROELECTRIC

CAPACITOR, METHOD OF FABRICATING THE SAME AND SEMICONDUCTOR

DEVICE METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF

MANUFACTURING FERROELECTIRC CAPACITOR, CERAMIC FILM,

FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE

Please replace the paragraph beginning on page 7, line 15, with the following rewritten paragraph:

In this embodiment of the present invention, the first metal and the second metal are the same as defined for the above method of manufacturing the first-ferroelectric capacitor.